



PATENT
Attorney Docket No.: SAM-0396

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kun-Hyung Lee, *et al.*

Examiner: Adams, Gregory W.

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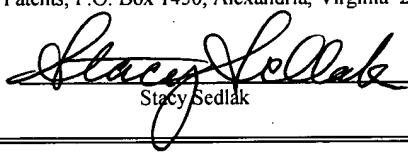
Title: APPARATUS AND METHOD FOR PROCESSING WAFERS

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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Stacy Sedlak

Stacy Sedlak

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT A

Sir:

The following is in response to the Office Action dated May 6, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 10 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 11 of this paper.

An Appendix including amended drawing figures is attached following page 13 of this paper.